

INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

FEB 08 2006

Docket Number (Optional)

LEE-0044

Application Number

NYA

Applicant(s)

Seung Don CHOI, et al.

Filing Date

December 8, 2005

Group Art Unit

NYA

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		1020020085675 A	11-16-2002	KOREA				
		2002-008718	1-11-2002	JAPAN				

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

/Patricia Davis/

DATE CONSIDERED

02/26/2009

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.